



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Ikuhito ONODERA

Group Art Unit: 2653

Application No.: 10/076,653

Examiner: C. MAGEE

Filed: February 19, 2002

Docket No.: 111984

For: METHOD FOR FABRICATING A THIN FILM MAGNETIC HEAD AND WAFER  
STRUCTURE

**AMENDMENT UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the July 14, 2005, Office Action, and in further reply to the November 10, 2005 Advisory Action, and in view of the attached Request for Continued Examination, the period for reply being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**